

AF/2800



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Application of: DARMAWAN

Attorney Docket No.: CREEP027/P0211

Application No.: 10/053,424

Examiner: TRAN, Tan

Filed: November 2, 2001

Group: 2826

Title: SILICON ON INSULATOR DEVICE  
WITH IMPROVED HEAT REMOVAL (As  
amended)

**CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as first-class mail on May 15, 2003 in an envelope addressed to the Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450.

Signed: Kristina Gomez  
Kristina Gomez

**AMENDMENT AF TRANSMITTAL**

Mail Stop : Box AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

RECEIVED  
MAY 20 2003  
TECHNOLOGY CENTER 2800

Sir:

Transmitted herewith is an Amendment in the above-identified application.

The fee has been calculated as shown below.

	Claims After Amendment		Highest Previously Paid For	Present Extra	Small Entity Rate Fee	Large Entity Rate Fee
Total Claims	04	MINUS	23	00	x 9 =	x 18 =
Independent Claims	01	MINUS	03	00	x 42 =	x 84 =
Multiple Dependent Claim Present and Fee Not Previously Paid					\$140.00	\$280.00
Total					\$	\$0

- ☒ Applicant(s) believe that no (additional) Extension of Time is required; however, if it is determined that such an extension is required, Applicant(s) hereby petition that such an extension be granted and authorize the Commissioner to charge the required fees for an Extension of Time under 37 CFR 1.136 to Deposit Account No. 500388.
- ☒ Please charge the required fees, or any additional fees required to facilitate filing the enclosed response, to Deposit Account No. 500388 (Order No. CREEP027).

Respectfully submitted,  
BEYER WEAVER & THOMAS, LLP  
Henry K. Woodward  
Henry K. Woodward  
Reg. No. 22,672

P.O. Box 778  
Berkeley, CA 94704-0778



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

#12  
Amend  
B  
(NE)  
5/27/03  
only

In re application of: DARMAWAN

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Signed: \_\_\_\_\_

Kristina Gomez

AMENDMENT AFTER FINAL

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Final Office Action dated March 21, 2003, finally rejecting claims 15 and 21-23 in the above-identified patent application, this amendment is submitted to put the application in condition for allowance or in better condition for appeal.

Please amend the above-identified patent application as follows:

**Amendment to the Title** begins on page 2 of this Amendment.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 3 of this Amendment.

**Remarks/Arguments** begin on page 4 of this Amendment.

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10/053,424

**Amendment To The Title:**

Please amend the Title of the invention as follows.

B<sup>1</sup>

SILICON ON INSULATOR DEVICE WITH IMPROVED HEAT REMOVAL AND METHOD  
OF MANUFACTURE